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APPLICATION NUMBER	FILING OR 371(c) DATE	FIRST NAMED APPLICANT	ATTY. DOCKET NO./TITLE
10/559,135	02/11/2008	Tetsuji Togawa	2005-1890A

**CONFIRMATION NO. 7353**

513

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**Title:** Substrate Polishing Apparatus And Substrate Polishing Method

**Publication No.** US-2008-0139087-A1

**Publication Date:** 06/12/2008

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